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Sheet 1 of 1

Substitute Form PTO-1449 (Modified)  <b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary)  (37 CFR §1.98(b))	Department of Commerce Patent and Trademark Office	Attorney's Docket No. <b>10559-587001</b>	Application No. <b>10/081,992</b>
	Applicant <b>Been-Yih Jin et al.</b>		
	Filing Date <b>February 21, 2002</b>	Group Art Unit <b>2812</b>	

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
<del> </del>	<del>AA</del>	<del> </del>	<del> </del>	<del> </del>	<del> </del>	<del> </del>	<del> </del>	<del> </del>
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Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
<del>RP</del>	<del>AF</del>	<del>Chau et al., International Electron Devices Meeting 2000, San Francisco, CA, December 10-13, 2000.</del>
<del>RP</del>	<del>AG</del>	<del>Ghani et al., Symposium on VLSI Technology Digest of Technical Papers, Honolulu, HI, June 13-15, 2000.</del>
<del>RP</del>	<del>AH</del>	<del>Hubbard et al., "Thermodynamic stability of binary oxides in contact with silicon" J. Mater. Res., Vol. 11, No. 11, Nov. 1996.</del>

Examiner Signature <i>Ron Pompey</i>	Date Considered <b>2-05-05</b>
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	